

U.S. Department of Commerce, Patent and Trademark Office				Attorney Docket No.: 004-8063		
				Application No.: 10/686,471		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant(s): Mu-Jing Li et al.		
(Use several sheets if necessary)				Filing Date: October 15, 2003		
				Group Art Unit: 2825		
				Date Submitted: April 26, 2004		
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Examiner	Munado		Date Considered 1-7-06			
<p><small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</small></p>						

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				Date Submitted: September 3, 2003		
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